



Atty. Dkt. No. 040373-0381

IFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Tatsuo NAKAYAMA, et al.

Title: ELECTRODE, METHOD FOR MANUFACTURING
THE SAME AND SEMICONDUCTOR DEVICE
USING THE SAME

Appl. No.: 10/574,933

International Filing Date: 12/06/2004
371(c) Date: 4/7/2006

Examiner: Quach, Tuan N.

Art Unit: 2826

Confirmation Number: 5552

AMENDMENT AND REPLY UNDER 37 C.F.R. § 1.111

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This communication is responsive to the Non-Final Office Action dated March 13, 2007, concerning the above-referenced patent application.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this document.

Remarks/Arguments begin on page 6 of this document.

Please amend the application as follows: